

DEC. 7. 2004 1:02PM DECHERT LLP

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NO. 7723—P. 1

PTO/SB/97 (08-03)

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Signature

Raquel Garcia

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Application Number See attached Schedule A

Filing Date See attached Schedule A

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd.

Art Unit unassigned

Examiner Name unassigned

Attorney Docket Number See attached Schedule A

Note: Each paper must have its own certificate of transmission, or this certificate
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Change of Correspondence Address with attached Schedule A (3 pages)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd. Docket No.: See attached Schedule A
Serial No.: See attached Schedule A Art Unit: Not yet designated
Filing Date: See attached Schedule A Examiner: Not yet designated

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

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CHANGE OF CORRESPONDENCE ADDRESSES

Applicants respectfully requests the Examiner to change the correspondence address for the following applications as listed in the attached Schedule A to the address associated with the attorney of record:

Customer No.:	38,552		
Individual Name:	John W. Ryan		
Firm Name:	Dechert, LLP		
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If necessary, please charge any fees in connection with this submission or credit any overpayments to our Deposit Account No. 50-2787. If you have any questions regarding this submission, please contact the undersigned attorney at the local Washington DC office.

Respectfully submitted,


John W. Ryan
Registration No. 33,771

Date: December 7, 2004

DECHERT, LLP
1775 I Street, N.W.
Washington, DC 20006

Schedule A
Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

P. 3

NO. 7723
Attorney Docket: 372106-101
Title: Resist Developer and Resist Pattern Formation Method Using Same
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/422,548	24-Apr-2003

Attorney Docket: 372106-102
Title: SILICA-BASED ORGANIC FILM AND METHOD OF
MANUFACTURING THE SAME, AND BASE MATERIAL
COMPRISING ORGANIC FILM
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/616,731	10-Jul-2003
US	10/800,822	15-Mar-2004

DECHERT LLP
Attorney Docket: 372106-103
Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST
PATTERN FORMATION METHOD
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/466,172	14-Jul-2003

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Schedule A

Change of Correspondence Address

Client: Tokyo Ohka Kogyo Co., Ltd

Customer Number: 38,552

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Attorney Docket: 372106-104

NO. 7723

**Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST
PATTERN FORMATION METHOD**

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/466,473	14-Jul-2003

Attorney Docket: 372106-105

Title: PHOTORESIST PATTERN AND FORMING METHOD THEREOF
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/628,919	29-Jul-2003

Attorney Docket: 372106-106

**Title: Positive Type Resist Composition and Resist Pattern Formation
Method Using Same**
Client: Tokyo Ohka Kogyo Co., Ltd.

DECHERT LLP

Country	Application Number	Filing Date
US	10/467,130	01-Aug-2003

Attorney Docket: 372106-107

Title: BASE MATERIAL FOR LITHOGRAPHY
Client: Tokyo Ohka Kogyo Co., Ltd.

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Country	Application Number	Filing Date
US	10/648,762	26-Aug-2003

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Schedule A
Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

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Attorney Docket: 372106-108

Title: Preparation for Nano Material, Metal Oxide Nano Material Formation
Composition Used for the Method, Mold and Metal Oxide Nano
Structure

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/840,192	06-May-2004

Attorney Docket: 372106-109

Title: Resist Composition
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/845,620	13-May-2004

Attorney Docket: 372106-110

Title: Positive Resist Composition and Formation Method of Resist Pattern
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/859,904	03-Jun-2004

Attorney Docket: 372106-111

Title: Positive Resist Composition and Resist Pattern Forming Method
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/865,040	10-Jun-2004

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